

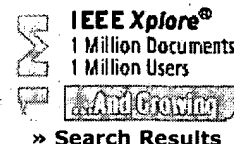
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van Heteren, J.G.; Fenzi, N.; James, T.W.; Bourne, L.C.;

Nuclear Science Symposium and Medical Imaging Conference, 1993., 1993 IEEE Conference Record. , 31 Oct.-6 Nov. 1993

Pages:1708 - 1712 vol.3

[\[Abstract\]](#) [\[PDF Full-Text \(328 KB\)\]](#) IEEE CNF

2 Axially-resolved study of highly ionized magnetron sputtering

Dickson, M.; Qian, F.; Hopwood, J.;

Plasma Science, 1996. IEEE Conference Record - Abstracts., 1996 IEEE International Conference on , 3-5 June 1996

Pages:184

[\[Abstract\]](#) [\[PDF Full-Text \(112 KB\)\]](#) IEEE CNF

3 The characteristics of magnetically enhanced large area processing plasmas

Cho, B.U.; Park, S.E.; Lee, J.K.; Lee, Y.J.; Yeom, G.Y.;

Plasma Science, 2003. ICOPS 2003. IEEE Conference Record - Abstracts. The 30th International Conference on , 2-5 June 2003

Pages:161

[\[Abstract\]](#) [\[PDF Full-Text \(174 KB\)\]](#) IEEE CNF

4 Modeling the inductively coupled plasma source and the comparison with experiments

Sheu, L.-R.; Hu, Y.; Lin, T.-L.; Tsai, S.-C.; Leou, K.-C.;

Plasma Science, 1998. 25th Anniversary. IEEE Conference Record - Abstracts. 1998 IEEE International on , 1-4 June 1998

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